



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Qi Xiang

Title: SILICON ON INSULATOR SUBSTRATE
HAVING IMPROVED THERMAL
CONDUCTIVITY AND METHOD OF ITS
FORMATION

Application No.: 10/658,668

Filing Date: 9 September 2003

Examiner: H. TRINH

Art Unit: 2814

CERTIFICATE OF EXPRESS MAILING
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REPLY TO OFFICIAL ACTION OF 1 JUNE 2005
UNDER 37 CFR §1.116

Mail Stop AF
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Sir:

Applicant hereby replies to the official action mailed 1 June 2005.

Reconsideration in view of the following amendments and remarks is requested.